

This listing of claims will replace all prior versions, and listings, of claims in the application:

**Listing of Claims:**

1           1.       (Currently Amended) A method for the simultaneous determination of  
2 a sample thickness **L** and index of refraction **n**, the method comprising:

3           a) forming said sample with a first and a second surfaces, wherein the first  
4 and second surfaces are substantially locally flat;

5           b) forming a radiation beam and impinging said radiation beam onto said  
6 sample at a first incidence angle  $A_1$  relative to an axis perpendicular to said first  
7 surface;

8           c) reflecting said impinged radiation beam from said first and said second  
9 surfaces of said sample forming a first and a second reflected radiation beams;

10          d) impinging said first and second reflected radiation beams on a detection  
11 device;

12          e) measuring a distance  $d_1$  on said ~~array~~ detection device between an  
13 impingement point of said first reflected beam and an impingement point of said  
14 second reflected radiation beam;

15          f) altering said first incidence angle to a second incidence angle  $A_2$  and again  
16 measuring a distance  $d_2$  between an impingement point of a third reflected beam and  
17 an impingement point of a fourth reflected beam on said detection device;

18          g) obtaining the sample thickness **L** and sample index of refraction **n** from the  
19 following equations:

20            $d_1 = [2 \cdot L / n] \cdot [\sin A_1 / (1 - (\sin^2 A_1) / n^2)^{1/2}]$  and

21            $d_2 = [2 \cdot L / n] \cdot [\sin A_2 / (1 - (\sin^2 A_2) / n^2)^{1/2}]$

1           2.       (Currently Amended) A method for the simultaneous determination of  
2 a sample thickness **L** and index of refraction **n**, the method comprising reflecting a  
3 radiation beam at a first incidence angle  $A_1$  onto a sample having a first and a second  
4 parallel reflective surfaces, wherein the first and second surfaces are substantially  
5 locally flat, and projecting a first surface reflected radiation beam and a second  
6 surface reflected radiation beam onto a detection device, determining a distance  $d_1$

7 between said projected reflection beams onto said detection device, altering said  
8 incidence angle to a second incidence angle  $A_2$  and measuring a second distance  $d_2$   
9 between said projected reflection beams onto said detection device, and solving the  
10 following system of equations:

11 
$$d_1 = [2 \cdot L / n] \cdot [\sin A_1 / (1 - (\sin^2 A_1) / n^2)^{1/2}] \text{ and}$$

12 
$$d_2 = [2 \cdot L / n] \cdot [\sin A_2 / (1 - (\sin^2 A_2) / n^2)^{1/2}]$$

13 to obtain values for  $L$  and  $n$ .

1 3. (Original) A method for the simultaneous determination of a sample  
2 thickness  $L$  and index of refraction  $n$ , the method comprising:

3 a) directing along an axis forming a first angle  $A_1$  with said sample a radiation  
4 beam, transmitting said radiation beam through said sample, intercepting said  
5 transmitted radiation beam by a detection device and measuring a distance  $d_1$   
6 between a point on said detection device where said axis intercepts said detection  
7 device and a point on said detection device where said transmitted beam impinges  
8 on said detection device; and

9 b) directing said radiation beam along a second axis forming a second angle  
10  $A_2$  with said sample, again transmitting said radiation beam through said sample and  
11 measuring a second distance  $d_2$  between a point on said detection device where said  
12 second axis intercepts said detection device and a point on said detection device  
13 where said again transmitted beam impinges on said detection device; and

14 c) solving the following system of equations:

15 
$$d_1 = L [ \sin A_1 - (\sin 2A_1 / 2(n^2 - \sin^2 A_1)^{1/2}) ] \text{ and}$$

16 
$$d_2 = L [ \sin A_2 - (\sin 2A_2 / 2(n^2 - \sin^2 A_2)^{1/2}) ]$$

17 to obtain values for  $L$  and  $n$ .

1 4. (Original) The method according to any one of claims 1-3 wherein the  
2 detection device comprises a photo-detector.

1 5. (Original) The method according to any one of claims 1-3 wherein  
2 angle  $A_1$  and angle  $A_2$  are both greater than 10 degrees.

1 6. (Original) The method according to any one of claims 1-3 wherein the  
2 radiation beam is monochromatic.

1           7.       (Original) The method according to any one of claims 1-3 wherein the  
2 radiation beam is collimated.

1           8.       (Original) The method according to any one of claims 1-3 wherein the  
2 radiation beam is a laser beam.

1           9.       (Currently Amended) The method according to any one of claims 1-3  
2 wherein the sample is transmits a portion of the radiation beam.

1           10.      (Original) The method according to any one of claims 1-3 wherein the  
2 sample is a liquid in a cuvette.

1           11.      (Original) The method according to any one of claims 1-3 wherein the  
2 first and the second surfaces of the sample are parallel.

1           12.      (Original) The method according to any one of claims 1-2 wherein the  
2 radiation beam is polarized and the incidence angles  $A_1$  and  $A_2$  both correspond to  
3 internal angles smaller than a total internal reflection angle at each of said surfaces.

1           13.      (Original) A method for the simultaneous determination of a sample  
2 thickness  $L$  and index of refraction  $n$ , the method comprising:

3           a) directing a substantially monochromatic collimated beam of radiation onto  
4 said sample along an axis forming a first angle  $A_x$  and a second angle  $A_y$  in a  
5 coordinate system having said sample in a plane defined by the x and y axis of said  
6 system, wherein said  $A_x$  is measured in a plane defined by the x and z axes and  $A_y$  in  
7 a plane defined by the y and z axes,

8           b) transmitting said beam through said sample and impinging said  
9 transmitted beam onto an array of radiation detectors arrayed in a plane parallel to  
10 said x-y plane;

11           c) measuring a first distance  $d_x$  on the x-axis between a point where said axis  
12 of monochromatic collimated beam impinges on said array of radiation detectors and  
13 a point where the monochromatic collimated beam impinges on said array of  
14 radiation detectors,

15           d) measuring a second distance  $d_y$  on the y-axis between a point where said  
16 axis of monochromatic collimated beam impinges on said array of radiation detectors  
17 and a point where the monochromatic collimated beam impinges on said array of  
18 radiation detectors; and

19 e) solving the following system of equations:

20  $d_x = L [\sin A_x - (\sin 2A_x \div 2(n^2 - \sin^2 A_x)^{1/2})]$  and

21  $d_y = L [\sin A_y - (\sin 2A_y \div 2(n^2 - \sin^2 A_y)^{1/2})]$

22 to obtain values for **L** and **n**.

1 14. (Currently Amended) A method for the simultaneous determination of  
2 a sample thickness **L** and index of refraction **n**, the sample having substantially  
3 parallel first and second surfaces lying in an x-y plane of a Cartesian co-ordinate  
4 system having x, y and z axes, the two surfaces separated by said distance **L**  
5 measured along the z axis, the method comprising:

6 a) directing an incident radiation beam of substantially collimated  
7 monochromatic radiation onto said sample, said radiation beam forming an angle  $A_x$   
8 in the x-z plane and an angle  $A_y$  in the y-z plane relative to the z axis;

9 b) reflecting said incident radiation off said first and said second surfaces;

10 c) intercepting said reflected incident radiation from said first and second  
11 surfaces with an array of radiation sensors and determining a first distance  $d_x$  and  
12 a second distance  $d_y$  between a point of incidence on said array of radiation  
13 sensors of said radiation beam reflected from said first surface and a point of  
14 incidence of said radiation beam reflected off said second surface measured along  
15 said x axis and said y axis respectively; and

16 d) solving the following equations simultaneously for said thickness **L** and said  
17 index of refraction **n**:

18  $d_x = [2.L/n].[\sin A_x / (1 - (\sin^2 A_x) / n^2)^{1/2}]$  and

19  $d_y = [2.L/n].[\sin A_y / (1 - (\sin^2 A_y) / n^2)^{1/2}]$

1 15. (Original) The method according to claims 13 or 14 wherein said array  
2 of radiation sensors is a single two dimensional CCD sensor or an array of CCD  
3 sensors.

1 16. (Currently Amended) The method according to claims 13 or 14  
2 wherein said array of radiation sensors is connected with a computer and said  
3 computer is programmed to measure the distances  $d_1, d_2, d_x$  or  $d_y$  on said array of  
4 radiation sensors.

1           17.    (Original) The method according to claim 16 wherein said computer is  
2 also programmed to solve said equations for **L** and **n**.

1           18.    (Currently Amended) A system for the simultaneous determination of  
2 a sample thickness **L** and index of refraction **n**, the sample having substantially  
3 parallel first and second surfaces, comprising:

4           a) a radiation beam along a path;

5           b) a holder adapted to hold said sample in said beam path at an adjustable  
6 angle relative to said sample surfaces;

7           c) a radiation detector placed to receive said radiation beam after said beam  
8 has impinged on said sample, the radiation detector comprising an array of sensors;

9           d) measuring means for measuring a distance between a reference point on  
10 said radiation detector and a point of impingement of said beam on said radiation  
11 detector

12           e) means for outputting an output indicative of ~~said measured distance~~ the  
13 sample thickness **L** and index of refraction **n**, wherein the output indicative of the  
14 sample thickness and index of refraction is determined from the distance measured  
15 by the measuring means.

1           19.    Cancelled.

1           20.    (Original) The system of claim 18 wherein the sample is a liquid in a  
2 cuvette.

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**Amendments to the Drawings:**

The attached sheets of drawings includes changes to Figures 3 and 4. These sheets replace the original sheets.

Attachment